



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| <u>In re application of:</u> Kangguo Cheng | <u>Filed:</u> 09/16/2003 |
| Serial No. 10/605227 | <u>Examiner:</u> K. L. Rose |
| Title: Method and Structure of Vertical Strained Silicon Devices | <u>Group Art Unit:</u> 2822 |
| | <u>Docket #:</u> FIS920030221US1 |

Enter
WPRCE
8/27/05

PRELIMINARY AMENDMENT

Commissioner of Patents & Trademarks
Alexandria, VA 22313

Sir:

Please amend the above identified application as follows: